

Date

For:

September 17, 2003

In re the Application of

Masaru MITSUI et al.

Application No.: 09/509,472

Filed:

April 21, 2000

PHOTOMASK BLANK, PHOTOMASK, METHODS OF MANUFACTURING THE SAME

AND METHOD OF FORMING MICROPATTERN LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION

Group Art Unit:

Docket No.: 105875

Examiner:

1752

Y. Thornton

HE UNITED STATES PATENT AND TRADEMARK OFFICE

OF TIME UNDER 37 C.F.R. §1.136(a) AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired June 17, 2003, an extension of time for a period of three months is hereby requested. Attached hereto is our Check No. 146422 in the amount of \$930 in payment for:

Extension fee for response within first month pursuant to §1.136(a) (\$110.00) Extension fee for response within second month pursuant to §1.136(a) (\$410.00)

Extension fee for response within third month pursuant to §1.136(a) (\$930.00) \mathbf{X}

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

Registration No. 2

Joel S. Armstrong Registration No. 36,430

Christopher W. Brown Registration No. 38,025

JAO:JSA:CWB/rav

09/22/2003 CCHAU1

01 FC:1253

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400

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930.00 OP

DEPOSIT ACCOUNT USE **AUTHORIZATION**

Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461